



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/881,408  
Confirmation No. .... 8492  
Filing Date ..... June 13, 2001  
Inventor ..... Kie Y. Ahn, et al  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2814  
Examiner ..... T. Le  
Attorney's Docket No. .... MI22-1534  
Customer No. .... 021567  
Title: A Dielectric Layer Forming Method and Devices Formed Therewith

**RESPONSE TO NOVEMBER 19, 2003 OFFICE ACTION**

To: Commissioner for Patents  
PO Box 1450  
Art Unit 2814  
Alexandria, VA 22313-1450

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**AMENDMENTS**

No amendments.

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